

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:)
Hiroki et al.)
Serial No: 09/776,472)
Filed: February 2, 2001)
Art Unit: 1762)
Examiner: M. Cleveland)
For: Thin Film Formation)
Apparatus and Method of)
Manufacturing Self-Light)
Emitting Device Using)
Thin Film Formation)
Apparatus)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

August 26, 2003

Signature

Date August 26, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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AMENDMENT C

Dear Sir:

In response to the Office Action dated February 28, 2003, please amend the above-identified application as follows.

IN THE CLAIMS:

Please amend the claims as follows:

09/03/2003 AKELLEY 00000004 09776472

03 FC:1201
04 FC:1202

252.00 OP
252.00 OP